

FIG. 1

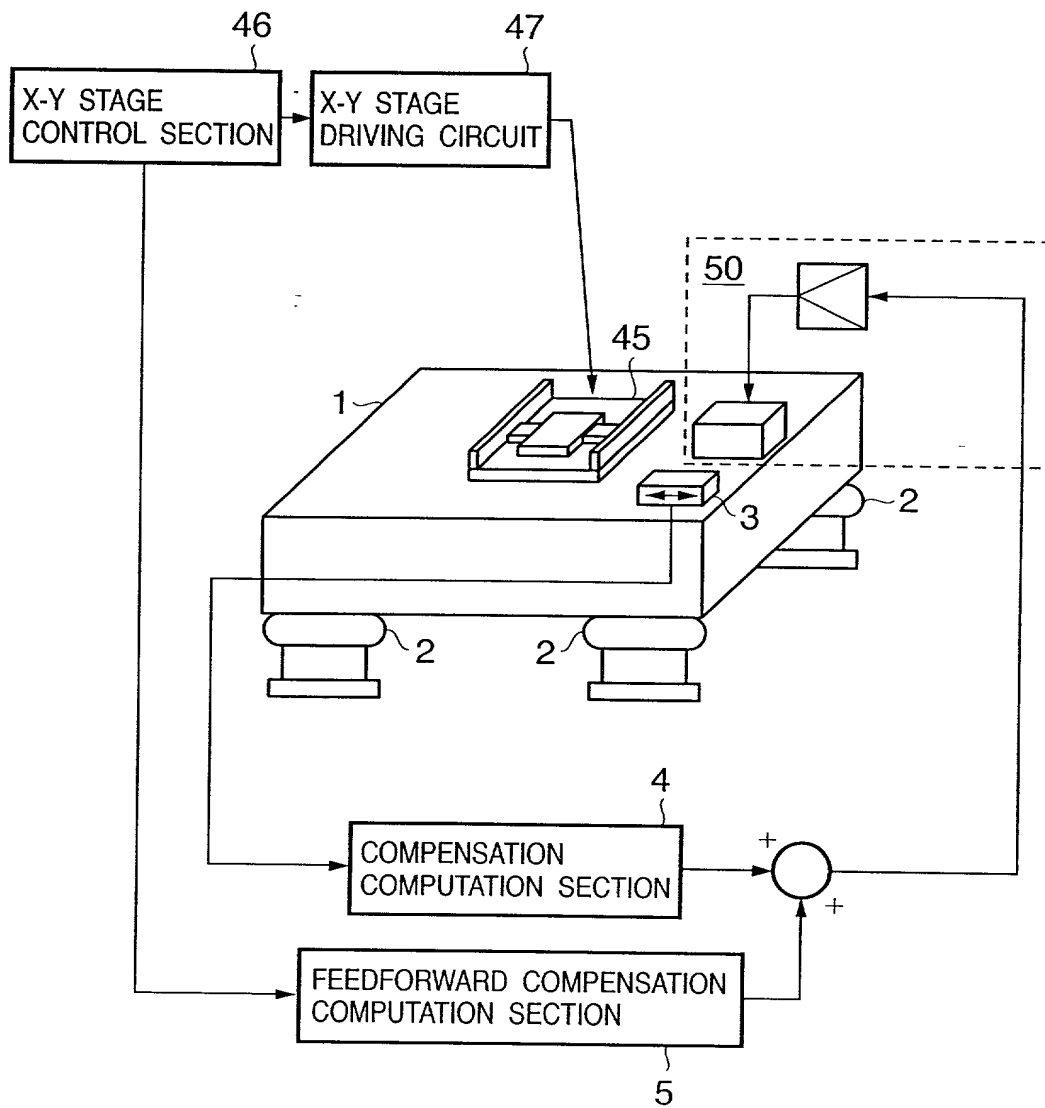


FIG. 2

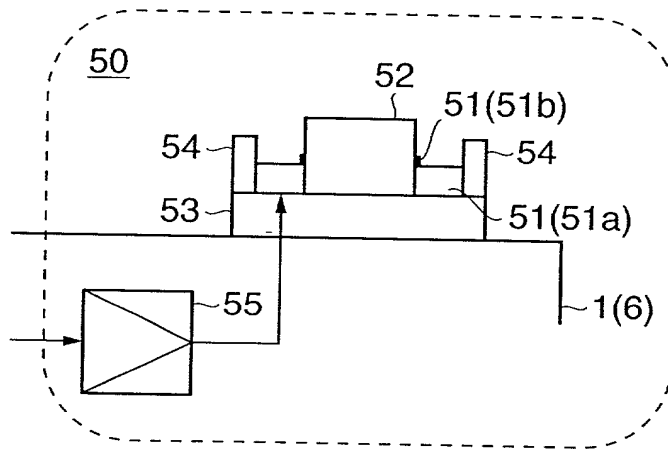


FIG. 3

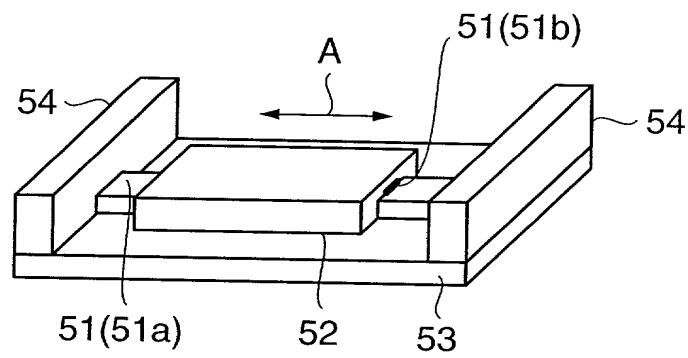


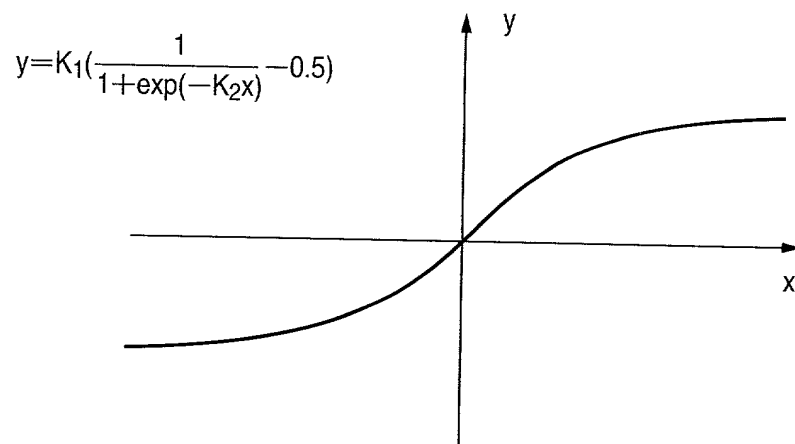
FIG. 4

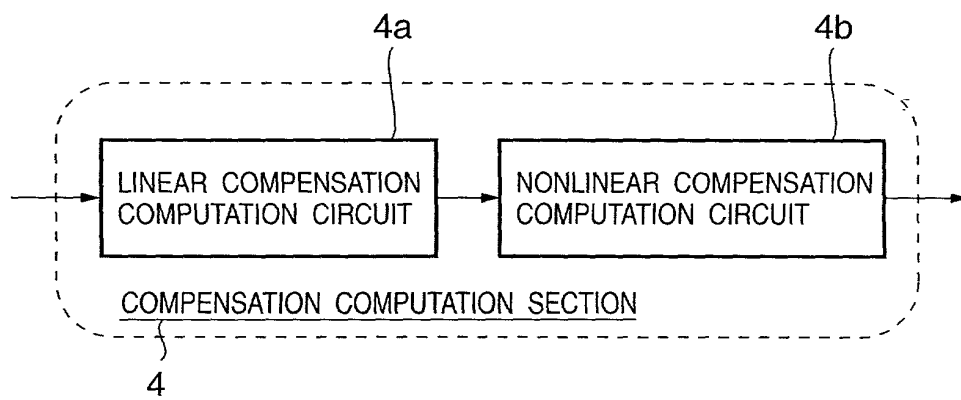
FIG. 5

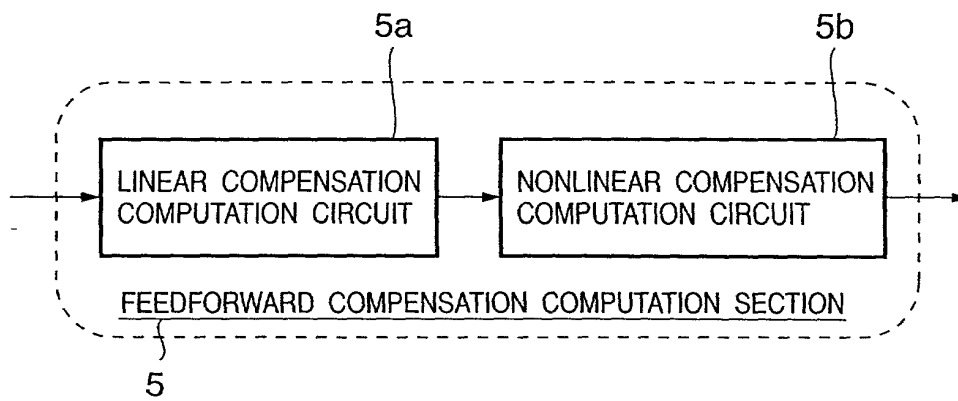
FIG. 6

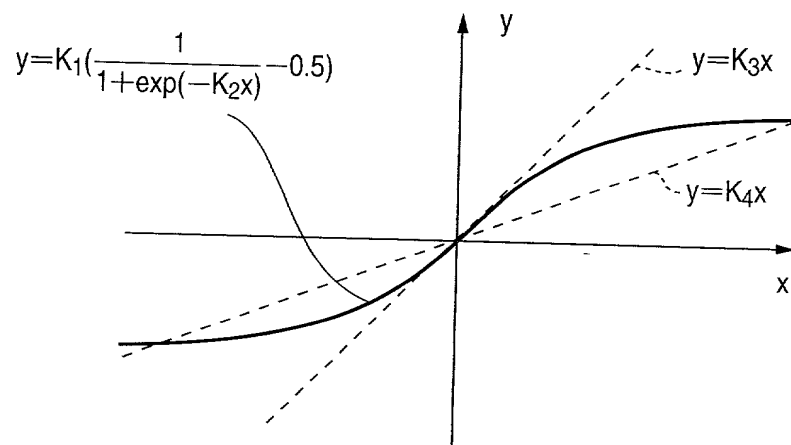
FIG. 7

FIG. 8

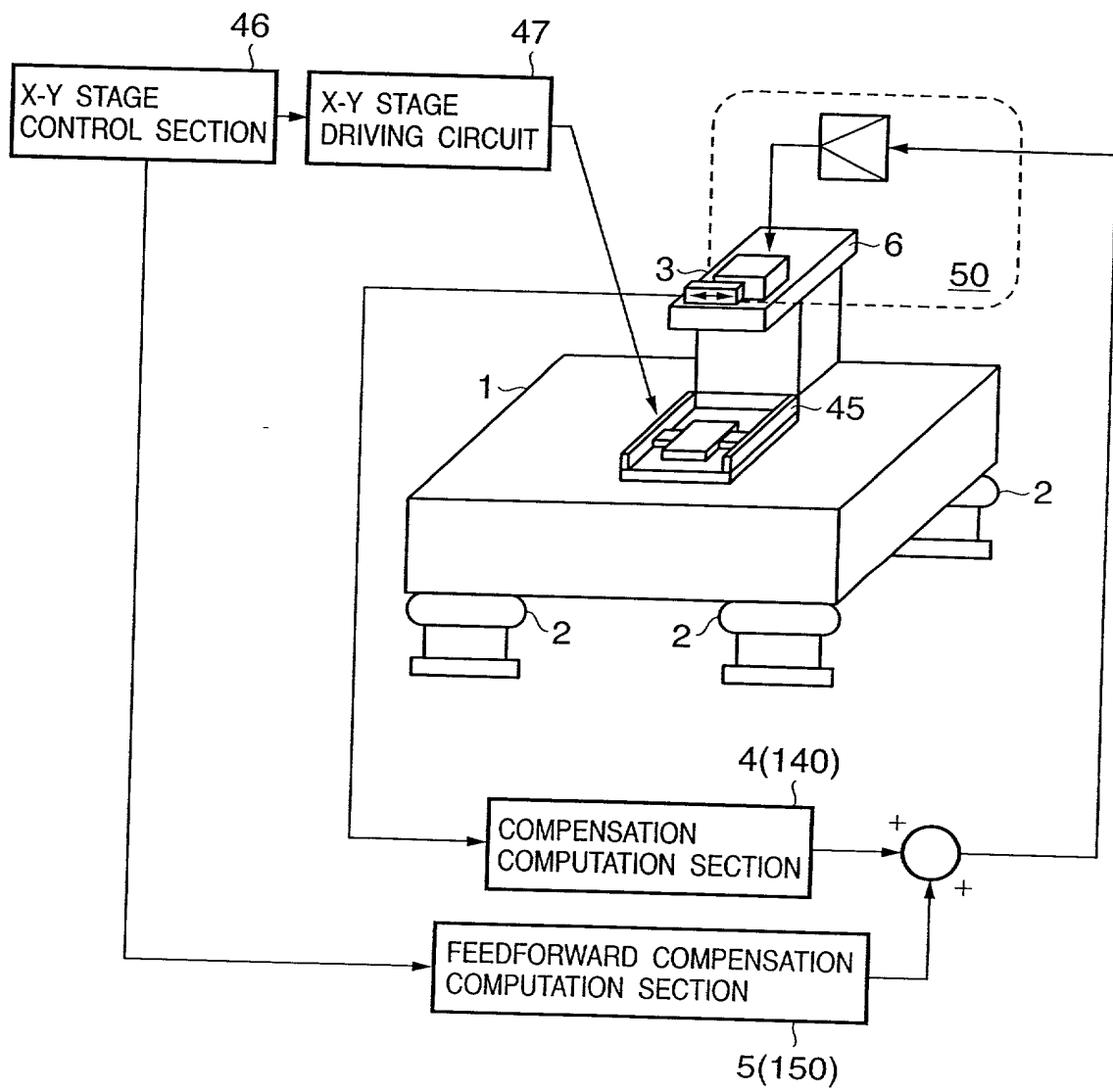
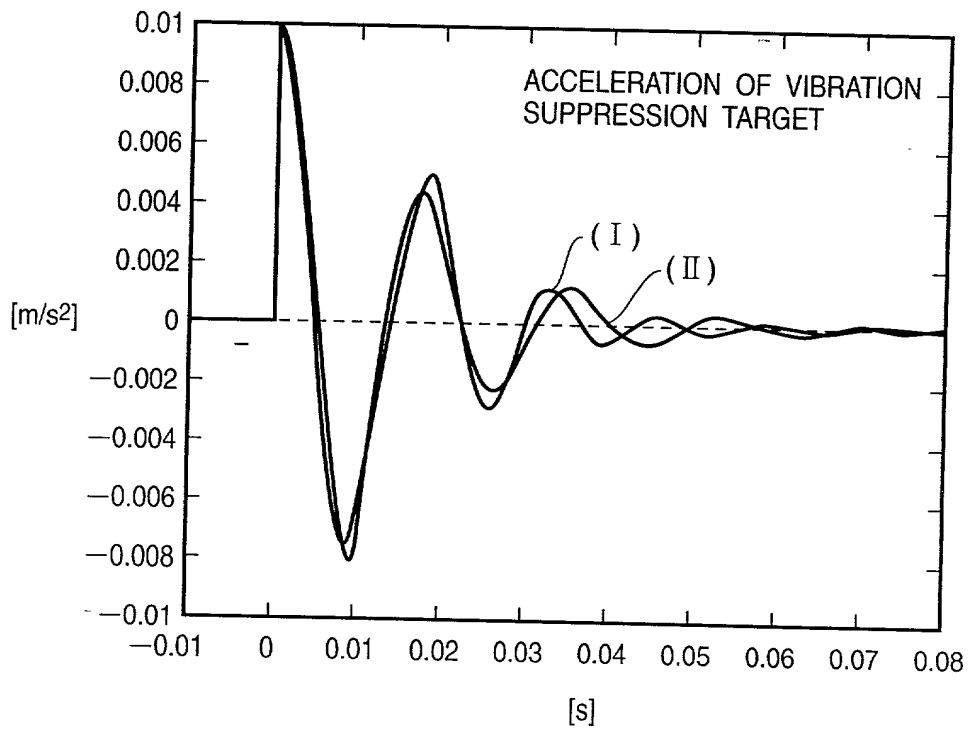
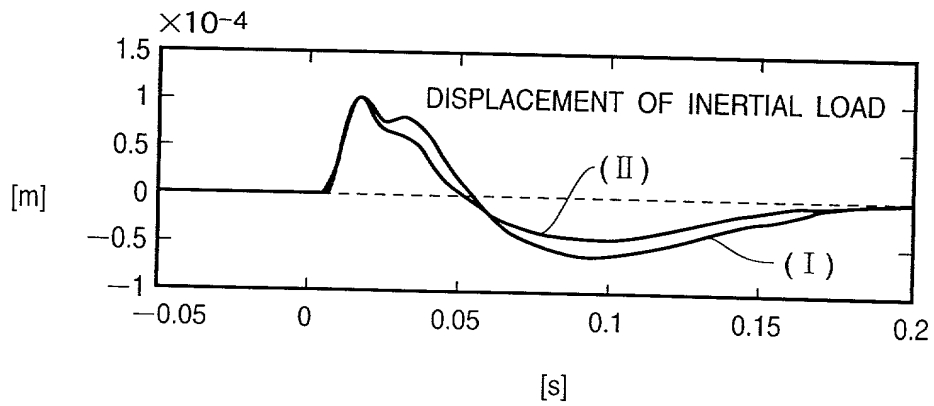


FIG. 9A**FIG. 9B**

10/23

FIG. 10

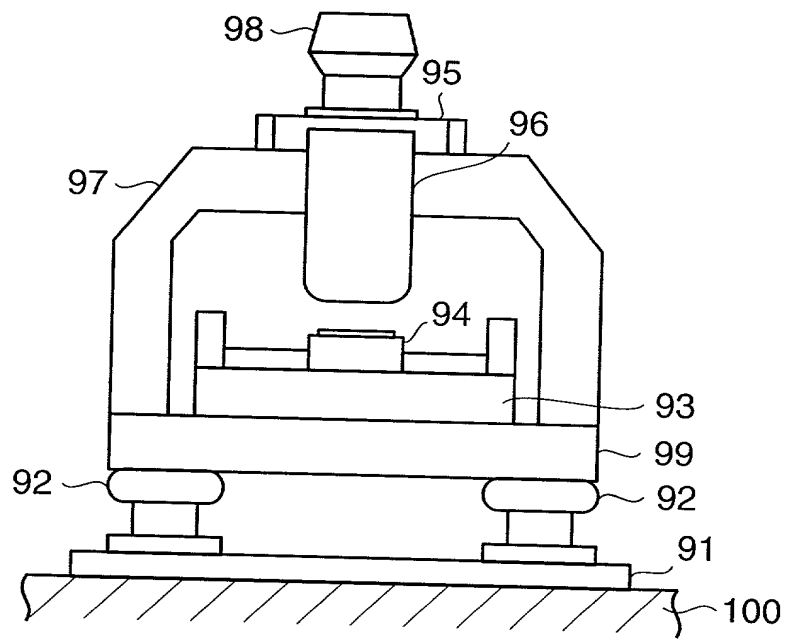


FIG. 11

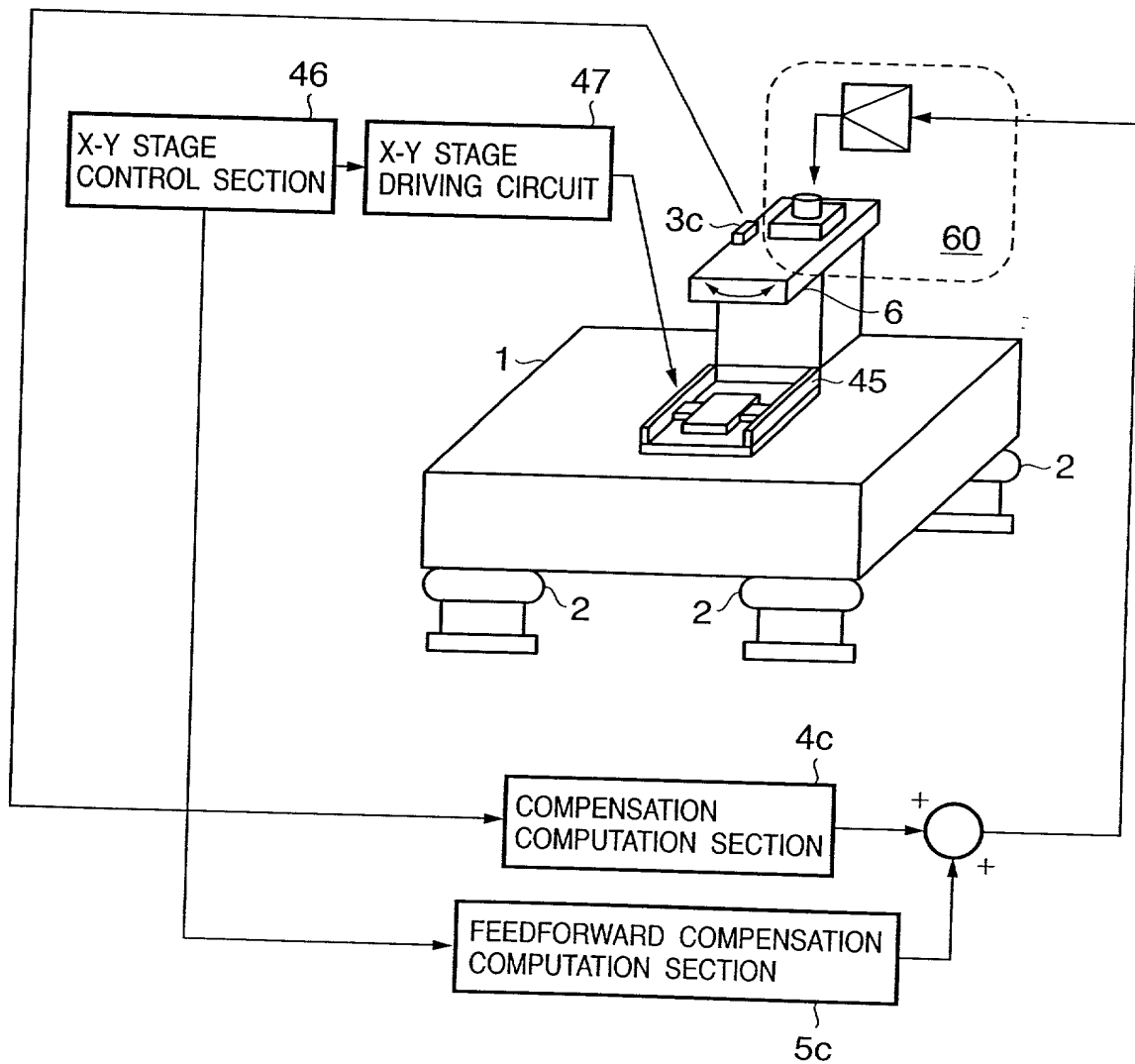


FIG. 12

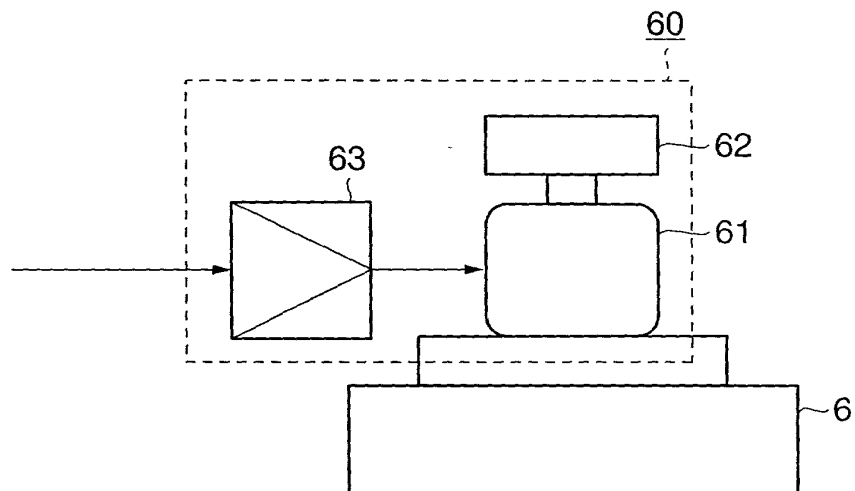


FIG. 13

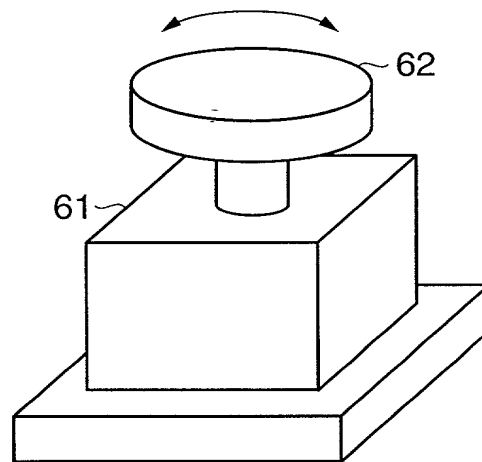


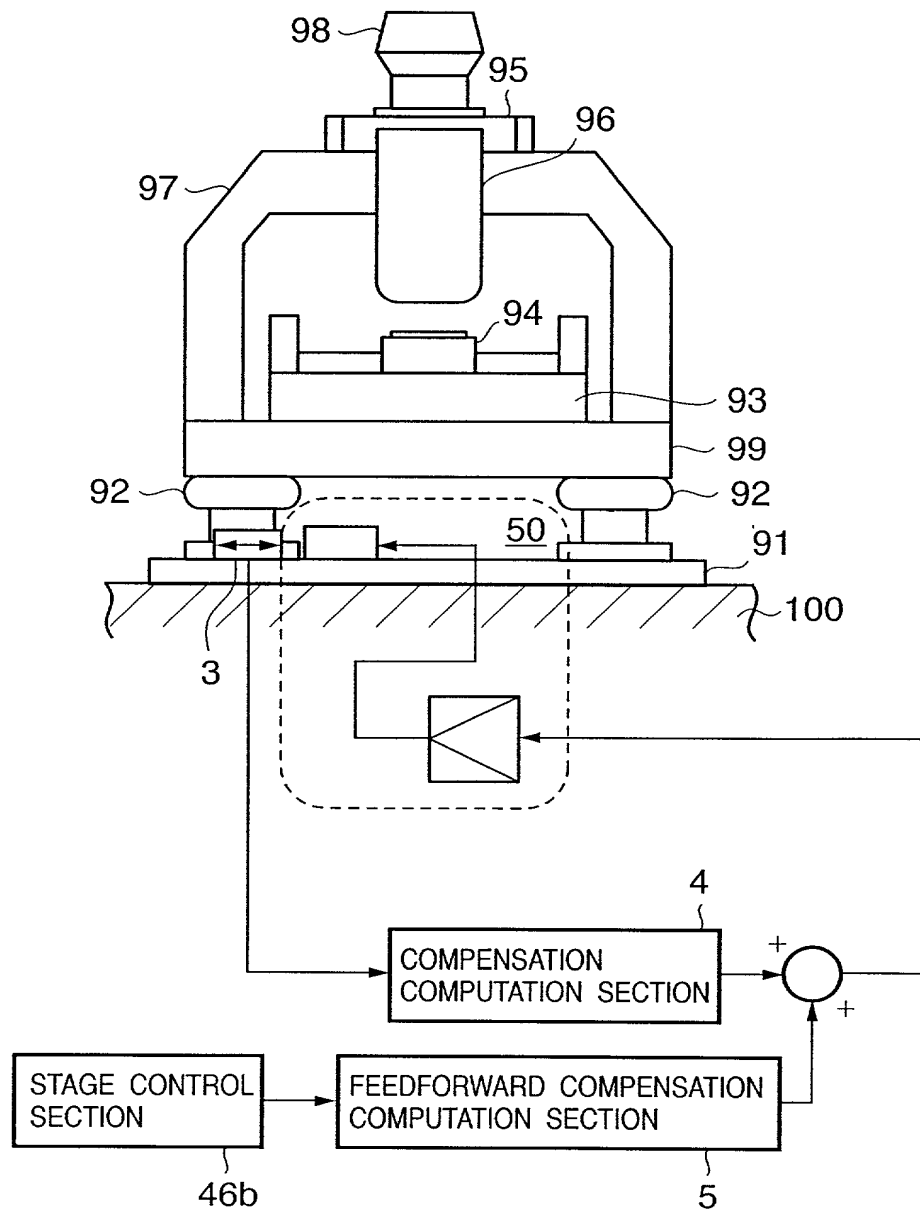
FIG. 14

FIG. 15

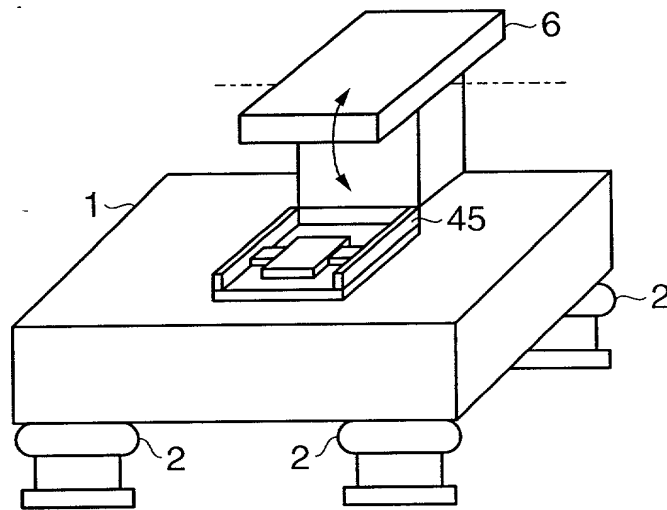


FIG. 16

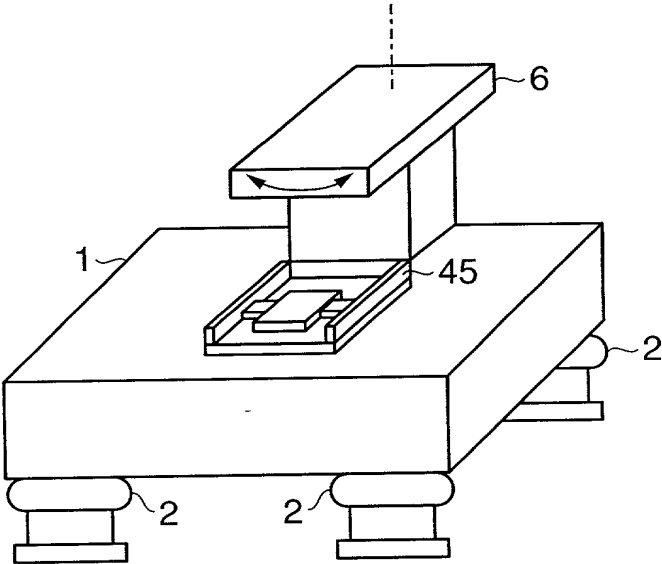


FIG. 17

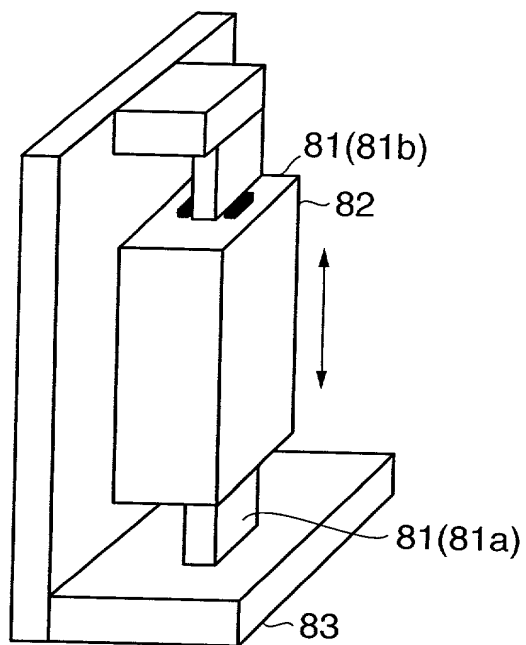


FIG. 18

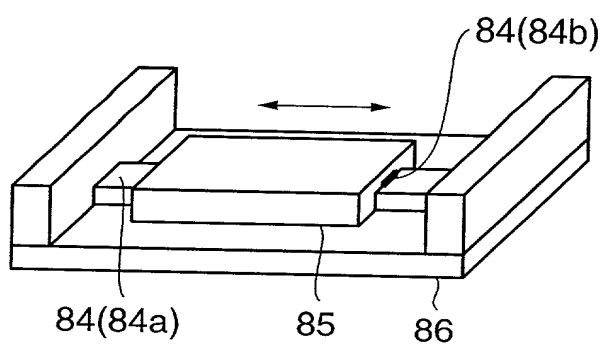


FIG. 19

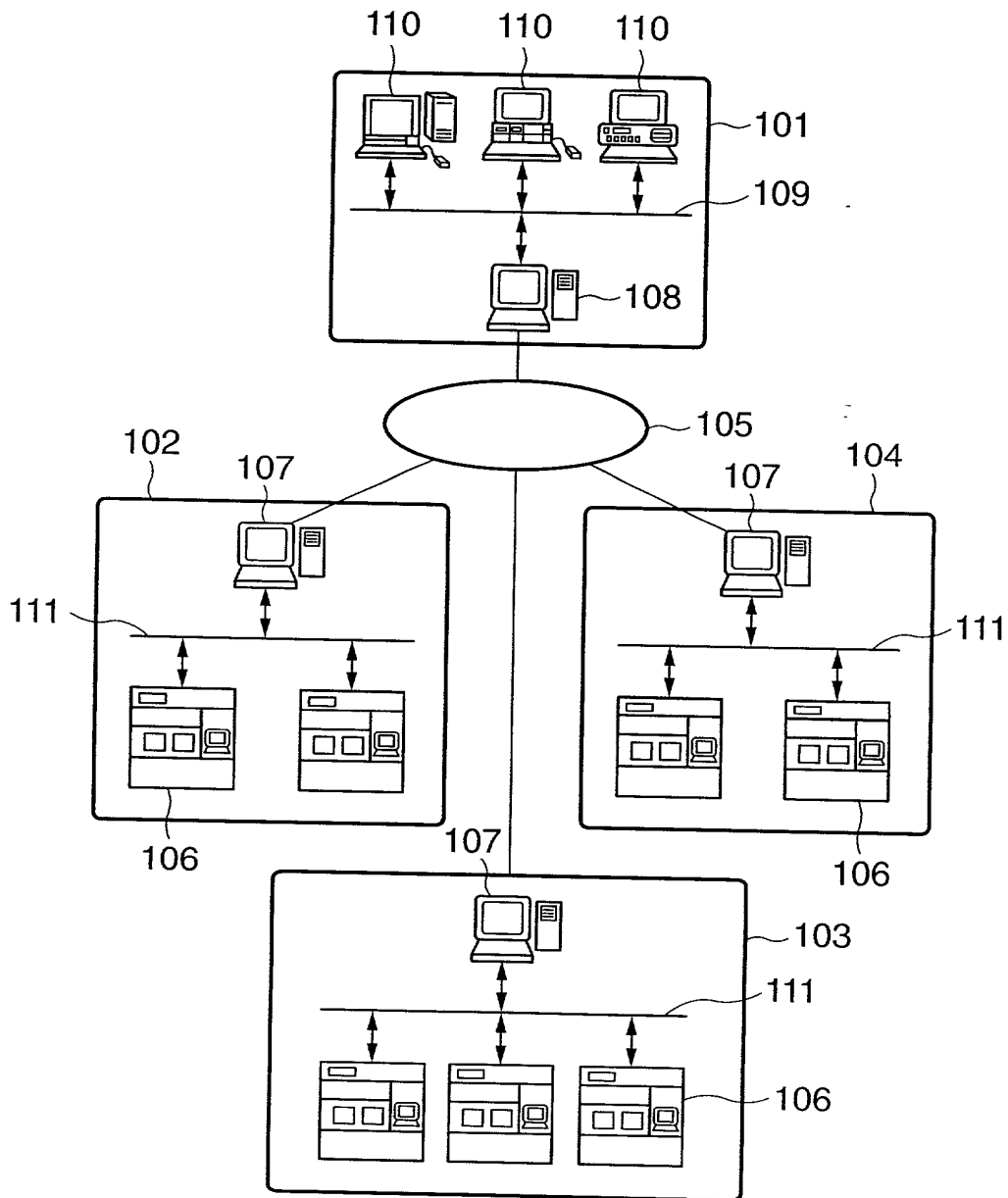


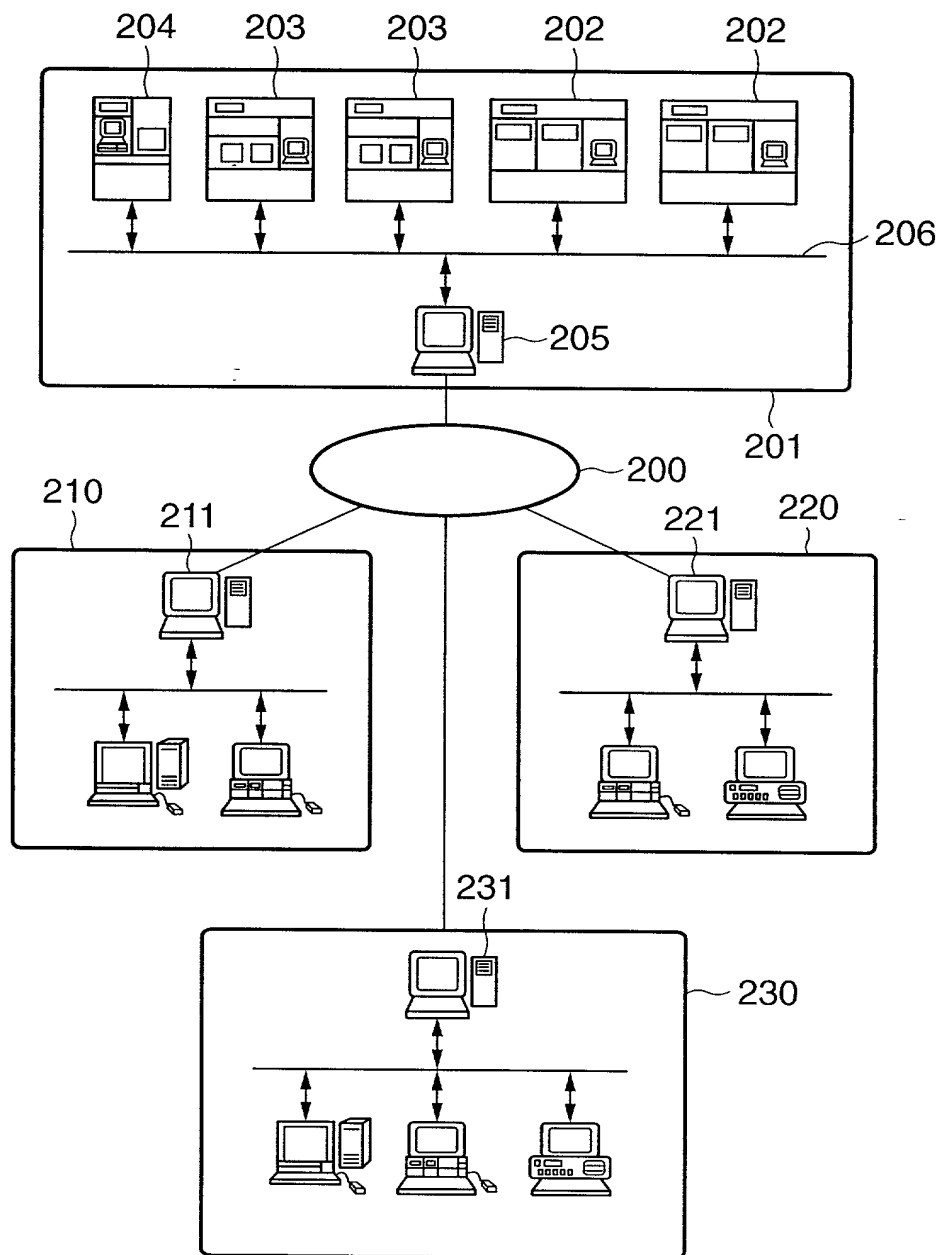
FIG. 20

FIG. 21

URL

TROUBLE DB INPUT WINDOW

DATE OF OCCURRENCE ~ 404

MODEL ~ 401

SUBJECT ~ 403

EQUIPMENT S/N ~ 402

URGENCY ~ 405

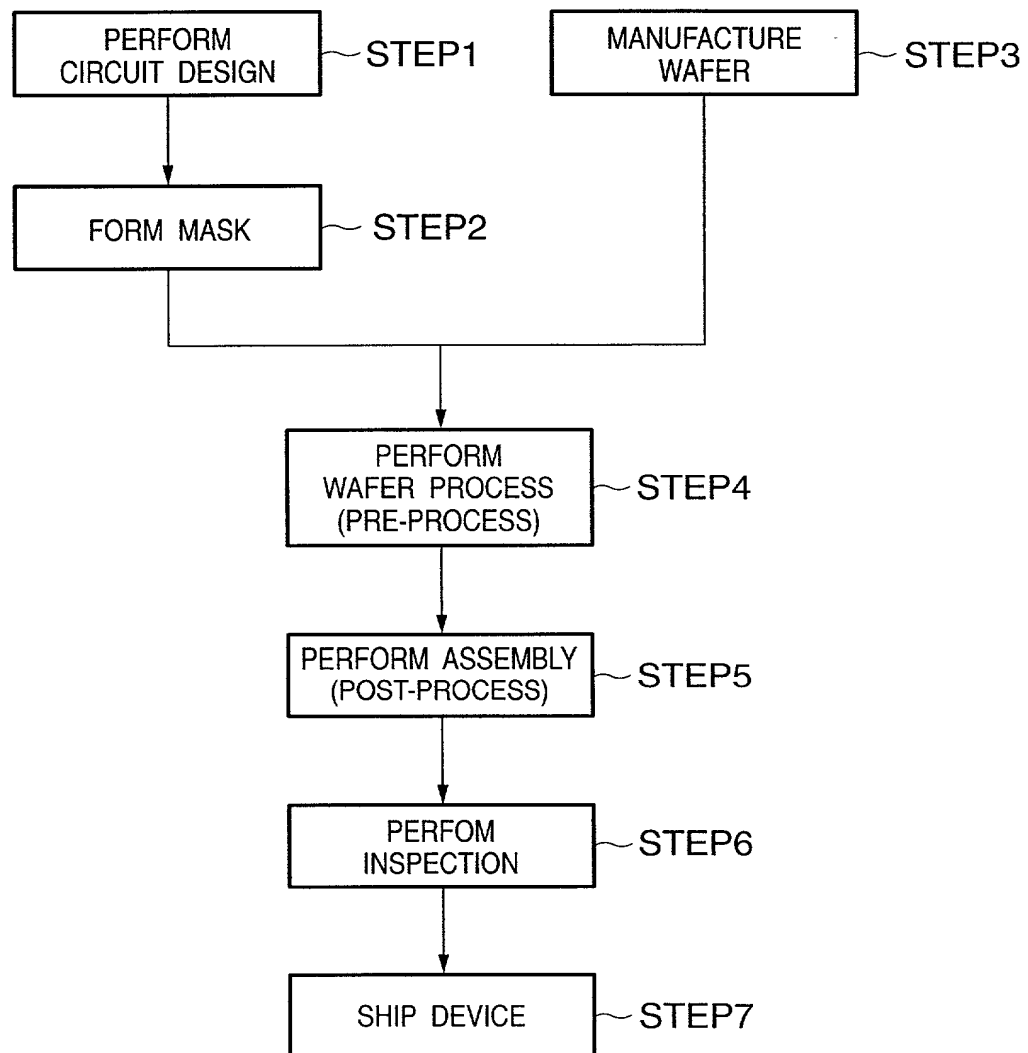
SYMPTOM ~ 406

REMEDY ~ 407

PROGRESS ~ 408

410 411 412

[LINK TO RESULT LIST DATABASE](#) [SOFTWARE LIBRARY](#) [OPERATION GUIDE](#)

FIG. 22

FLOW CHART OF SEMICONDUCTOR DEVICE MANUFACTURING PROCESS

FIG. 23

